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Karen Cinq-Mars

(Signature)

(Date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of : December 27, 2001
Ausschnitt et al. :
Serial No. : Examiner:
Filed: Herewith : IBM Corporation
Dept. 18G/Bldg. 300-482
2070 Route 52
Hopewell Junction,
New York 12533-6531
Title: PHASE SHIFTED TEST PATTERN
FOR MONITORING FOCUS AND ABERRATIONS
IN OPTICAL PROJECTION SYSTEMS :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sirs:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to
the documents listed on the enclosed Form PTO-1449. Copies of the
listed documents are also enclosed.

It is respectfully requested that the above information be
considered by the Examiner and that a copy of the enclosed Form
PTO-1449 be returned indicating that such information has been
considered.

Applicants' undersigned attorney may be reached by telephone
at (845) 894-6919. All correspondence should continue to be

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#2/IDS
2/15/02
C. McKinnon
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directed to the below listed address.

Respectfully submitted,

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